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AF

Docket No.: M4065.0278/P278
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Kevin L. Beaman, et al.

Examiner: Richard A. Booth

Application No.: 09/653,281

Art Unit: 2812

Filed: August 31, 2000

For: USE OF ATOMIC OXIDATION FOR
FABRICATING OF OXIDE-NITRIDE-OXIDE
STACK FOR FLASH MEMORY DEVICES

REQUEST FOR RECONSIDERATION

Commissioner for Patents
MS: AF
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated May 11, 2006, finally rejecting claims 1-3, 6-14, 16, 18, 21-29, 31 and 36-45, please reconsider the above-identified U.S. patent application in light of the following remarks.